

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

**Title of
Invention**

**DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE
FABRICATION**

Application Number :

Confirmation Number:

First Named Applicant: June Cline

Attorney Docket Number: BUR920040122US1

Art Unit:

Examiner:

Search string: (6676800 or 6318384 or 6235214 or 6127278 or 6020269 or 5807789).pn

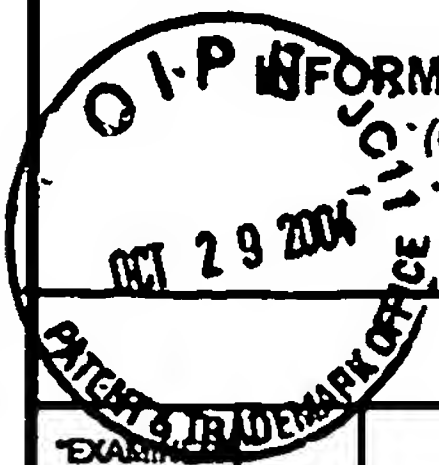
US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
EC	1	6676800	2004-01-13	Festa et al			
/	2	6318384	2001-11-20	Khan et al			
/	3	6235214	2001-05-22	Deshmukh et al			
/	4	6127278	2000-10-03	Wang et al			
/	5	6020269	2000-02-01	Wang et al			
✓	6	5807789	1998-09-15	Chen et al			

Signature

Examiner Name	Date
<i>Eric Chen</i>	7/5/05



INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

ATTY DOCKET NO.

BUR920040122US1

APPLICATION NO.

10/711,953

APPLICANT(S)

June Cline et al.

FILING DATE

10-15-2004

GROUP ART UNIT

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EC			HANDBOOK OF THIN FILM TECHNOLOGY, Edited by Leon I. Maissel and Reinhard Glang, Copyright: 1970, p. 7-44.

EXAMINER

DATE CONSIDERED

7/5/05

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.